

INFORMATION DISCLOSURE CITATION
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#2
Takaaki Sasaki

FILING

OCT. 13, 2000

GROUP

[2822]

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>De</i>	A	4,664,578	5/12/87	KAKEHI	414	217	—
	B	4,735,548	4/5/88	KIMATA et al.	414	744R	PTO
	C	4,770,590	9/13/88	HUGUES et al.	414	172	5/22/90
	D	4,871,290	10/3/89	KACZYNSKI et al.	414	331	5/22/90
	E	5,135,349	8/4/92	LORENZ et al.	414	744.6	5/22/92
	F	5,584,647	12/17/96	UEHARA et al.	414	744.6	—
	G	5,447,409	9/5/95	GRUNES et al.	414	744.6	—
	H	5,372,471	12/13/94	WU	414	786	—
	I	5,288,199	2/22/94	ENOMOTO	414	749	—
	J	5,011,366	4/30/91	MILLER	414	786	—
<i>De</i>	K	4,030,309	6/21/77	MASON	61	69R	—

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
<i>De</i>	L	2,138,775	10/31/84	GREAT BRITAIN	—	—	X	
<i>De</i>	M	64-45827	2/26/88	JAPAN	—	—	X	
<i>De</i>	N	10-92972	4/98	JAPAN	—	—		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

De 0 IBM Technical Disclosure Bulletin, Vol. 24, No. 6, dated 11/81, pp.3017-3018, entitled "Vacuum Wafer Pick-Up Tip," by J.G. Ferrentino and L.H. Rosenfeld.

EXAMINER

DATE CONSIDERED

10/2003

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION
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Ticket Number (Optional) **PNET-011**

Application Number
09/689,824

Applicant(s)

Filing Date	Group Art Unit
October 13, 2000	2818

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<i>Sh</i> G	JP58178529A	10/19/1983	JAPAN			✓	

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

EXAMINER

DATE CONSIDERED

10/2002

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